

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant :	Budong You et al.	Art Unit :	2818
Serial No. :	10/713,749	Examiner :	Dung Anh Le
Filed :	November 13, 2003	Conf. No. :	1619
Title :	A LATERAL DOUBLE-DIFFUSED MOSFET		

MAIL STOP RCE

Commissioner for Patents
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INFORMATION DISCLOSURE STATEMENT

Applicants request consideration of the references listed on the attached PTO-1449 form. Under 37 C.F.R. § 1.98 (a)(2)(ii), only copies of foreign patent documents and/or non-patent literature are enclosed. Copies of any listed U.S. patents or U.S. patent application publications can be provided upon request.

This filing is being made with the filing of a Request for Continued Examination. No fee is required.

Respectfully submitted,

Date: 12/29/06



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Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 09464-025001	Application No. 10/713,749
Information Disclosure Statement by Applicant (Use several sheets if necessary)		Applicant Budong You et al.	
		Filing Date November 13, 2003	Group Art Unit 2818
(37 CFR §1.58(b))			

U.S. Patent Documents

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	4,769,686	09/1988	Horiuchi, et al.			
	AB	5,275,961	01/1994	Smayling, et al.			
	AC	5,349,225	09/1994	Redwine, et al.			
	AD	5,834,851	11/1998	Ikeda, et al.			
	AE	5,955,746	09/1999	Kim			
	AF	5,998,274	12/1999	Akram, et al.			
	AG	6,022,770	02/2000	Hook, et al.			
	AH	6,078,082	06/2000	Bulucea			
	AI	6,142,375	11/2000	Belka, et al.			
	AJ	6,489,209	12/2002	Shimoji			
	AK	6,518,835	02/2003	Ribo, et al.			
	AL	6,538,288	03/2003	Lee, et al.			
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	AP	7,074,659	07/2006	Zuniga, et al.			
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	AT	2002/0079514	06/2002	Hower, et al.			
	AU	2002/0089790	07/2002	Stoebe, et al.			
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	AW	2003/0141559	07/2003	Moscatelli, et al.			
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	AY	2005/0106791	05/2005	You, et al.			
	AZ	2005/0106825	05/2005	You, et al.			

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Substitute Form PTO-1449 (Modified) Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))	U.S. Department of Commerce Patent and Trademark Office		Attorney's Docket No. 09464-025001	Application No. 10/713,749
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	AAA	7,074,659	07/2006	Zuniga, et al.			
	ABB	7,038,274	05/2006	Budong You, et al.			
	ACC	11/232,516		Budong You, et al.			9/2005
	ADD	2006/0205168	09/2006	Zuniga, et al.			

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AEE							
	AFF							

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AGG	S. Wolf, "Silicon Processing for the VLSI Era", Volume 2 - Process Integration, page 662; Lattice Press, Sunset Beach, California 90742 (ISBN: 0-961672-4-5) (1990)
	AHH	S. Wolf, "Silicon Processing in the VLSI Era", Volume 3 - The Submicro MOSFET, pages 591-593, Lattice Press, Sunset Beach, California (1995)
	AII	Webster's Collegiate Dictionary, 10 th Edition, Springfield, Massachusetts (1999), page 222.
	AJJ	

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